



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 3887

SERIAL NUMBER 10/806,923	FILING DATE 03/22/2004 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. MI22-2274
-----------------------------	---------------------------------------	--------------	------------------------	----------------------------------

APPLICANTS

Weimin Li, Shanghai, CHINA;
 Gurtej S. Sandhu, Boise, ID;

** CONTINUING DATA ***** None AIC

** FOREIGN APPLICATIONS ***** None AIC

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 06/03/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature: <i>Ashwini Kumar</i> Initials: <i>AK</i>	STATE OR COUNTRY CHINA	SHEETS DRAWING 13	TOTAL CLAIMS 165	INDEPENDENT CLAIMS 7
--	------------------------------	-------------------------	------------------------	----------------------------

ADDRESS
 021567
 WELLS ST. JOHN P.S.
 601 W. FIRST AVENUE, SUITE 1300
 SPOKANE, WA
 99201

TITLE
 Methods of depositing silicon dioxide comprising layers in the fabrication of integrated circuitry, methods of forming trench isolation, and methods of forming arrays of memory cells

FILING FEE RECEIVED 3854	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
------------------------------------	---	---